

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/620,266	CHEN ET AL.	
Examiner	Art Unit	
Daniel D. Abebe	2626	

SEARCHED						
Subclass	Date	Examiner				
219 500	10/15/2007	DA				
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	Subclass 219	Subclass Date				

INT	INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner			
704	219 500	10/15/2007	DA			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
WEST	10/15/2007	DA		